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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Yoshihiro SUGITA et al.

Group Art Unit: 2823

Serial No.: 10/633,534

Examiner: Brook Kebede

Filed: August 5, 2003

Confirmation No.: 6460

For: MANUFACTURE METHOD FOR SEMICONDUCTOR DEVICE WITH
PATTERNEED FILM OF ZrO₂ OR THE LIKE

Attorney Docket Number: 030862

Customer Number: 38834

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCESSING REQUESTED

BOX AF

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

March 29, 2005

Sir:

In response to the Office Action dated December 16, 2004, the response date of which having been extended by one month to April 16, 2005, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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4/1/2005